



Attorney Docket No. 0756-2330

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/894,125

Filed: June 29, 2001

For: CRYSTALLINE SEMICONDUCTOR

THIN FILM, METHOD OF

FABRICATING THE SAME,

SEMICONDUCTOR DEVICE, AND

METHOD OF FABRICATING THE

SAME

) Group Art Unit: 2823

) Examiner: B. Kebede

) CERTIFICATE OF MAILING

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Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

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required now or hereafter, or credit any overpayment to Deposit Account No. 50-2280.

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Respectfully submitted,



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PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

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Sheet	1	of	1	Application Number	09/894,125
				Filing Date	June 29, 2001
				First Named Inventor	Shunpei YAMAZAKI et al.
				Group Art Unit	2823
				Examiner Name	B. Kebede
				Attorney Docket Number	0756-2330

U.S. PATENT DOCUMENTS

Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ³ (if known)			
		5,869,387		Sato et al.	02/09/1999	
		5,985,681		Hamajima et al.	11/16/1999	
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		6,559,036		Ohtani et al.	05/06/2003	

FOREIGN PATENT DOCUMENTS

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Attorney Docket No 56-2330

Serial No. Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Shunpei YAMAZAKI et al.

Filing Date: June 29, 2001

Group Art Unit: 2823

 11017 U.S. PTO
09/894125
06/29/01

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
BK	5,594,569	01/14/1997	Konuma et al.			
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	"Characteristics and Driving Scheme of Polymer-Stabilized Monostable FLCs Exhibiting Fast Response Time and High Contrast Ratio with Gray-Scale Capability", H. Furue et al., SID 1998
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Examiner Brook Kebede

Date Considered April 20, 2002

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June 29, 2001

First Named Inventor

Shumpei YAMAZAKI et al.

Group Art Unit

2823

Examiner Name

B. Kebede

Attorney Docket Number

740756-2330

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		Number	Kind Code ² (if known)			
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		Office ³	Number ⁴ Kind Code ² (if known)				

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Examiner Initials [*]	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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Examiner Signature

Brook Kebede

Date Considered

April 20, 2002